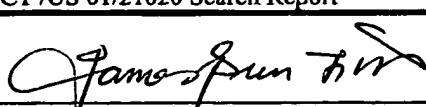




PTO-1449		Application No. 10/657,648		Applicant(s) Jeffry S. Schepp et al.				
<b>Information Disclosure Citation in an Application</b>		Docket Number 064441.0285		Group Art Unit <del>Unassigned</del> 2826	Filing Date September 8, 2003			
		<b>U.S. PATENT DOCUMENTS</b>						
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>	
92	A.	5416722	5/1995	Edwards	716	11	-	
	B.	5539975	07/30/96	Kukuljan et al.	29	701	09/08/93	
	C.	5625801	04/29/97	Fukuya	395	500	07/28/94	
	D.	5694551	12/1997	Doyle et al.	705	26	-	
	E.	5732218	03/24/98	Bland et al.	395	200.54	01/02/97	
	F.	5825651	10/20/98	Gupta et al.	364	468.09	09/03/96	
	G.	5844810	12/1998	Douglas et al.	700	56	-	
	H.	5870719	02/09/99	Maritzen	705	26	07/03/96	
	I.	5920846	07/06/99	Storch et al.	705	7	02/27/96	
	J.	5933350	8/3/99	Fujimoto et al.	364	468.28	3/27/97	
93	K.	5950201	9/7/99	Van Huben et al.	707	10	12/6/96	
<b>FOREIGN PATENT DOCUMENTS</b>								
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>	
							YES	NO
94	L.	1 003 087 A1	5/24/00	EP	G05B	19		X
	M.							
	N.							
<b>NON-PATENT DOCUMENTS</b>								
		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>					<b>DATE</b>	
95	O.	PCT Written Opinion PCT/US01/21020					Mailed 01/03/03	
96	P.	Peltier, J. et al. "Low cost, prototype ASIC and MCM fabrication and assembly from the MOSIS service" Proceedings. 1997 IEEE, pps. 68-69, XP002199595					1997	
97	Q.	Luo et al. "Desktop Rapid Prototyping System With Supervisory Control and Monitoring Through Internet" IEEE/ASME Transactions on Mechatronics Vol. 6, No. 4; pps. 399-409. XP002199596					Dec, 2001	
98	R.	PCT /US 01/21020 Search Report					Mailed Jun 6, 2002	
EXAMINER 					DATE CONSIDERED 1-27-05			
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PTO-1449		Application No. 10/657,648		Applicant(s) Jeffry S. Sch pp t al.				
Information Disclosure Citation in an Application		Docket Number 064441.0285		Group Art Unit <del>Unassigned</del> 2828	Filing Date September 8, 2003			
		U.S. PATENT DOCUMENTS						
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
92	A.	5963953	10/05/99	Cram et al.	707	102	03/30/98	
	B.	5969973	10/19/99	Bourne et al.	364	474.07	02/09/95	
	C.	6003012	12/14/99	Nick	705	10	12/05/97	
	D.	6009406	12/28/99	Nick	705	10	12/05/97	
	E.	6023565	2/2000	Lawman et al.	716	1	-	
	F.	6023699	02/8/00	Knoblock et al.	707	10	03/25/97	
92	G.	6330708	12/2001	Parker et al.	716	19	-	
	H.							
	I.							
	J.							
	K.							
	L.							
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FOREIGN PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	N							
	O							
	R							
NON-PATENT DOCUMENTS								
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE	
92	N.	Suttle et al., "Streamlining the frontend reticle fabrication process by improving mask ordering", MicroMagazine.com					June 2002	
92	O.	Photoplot Store at <a href="http://web.archive.org/web/20000614112553/http://www.photoplotstore.com/">http://web.archive.org/web/20000614112553/http://www.photoplotstore.com/</a>					June 2000	
	P.							
	Q.							
EXAMINER 					DATE CONSIDERED 1-27-05			
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